

Notice of References Cited	Application/Control No. 10/734,674		Applicant(s)/Patent Under Reexamination CHOI ET AL.	
	Examiner RICARDO L. OSORIO		Art Unit 2629	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0151565	08-2003	Kim et al.	345/60
*	B	US-2002/0180754	12-2002	Suzuki, Masahiro	345/598
*	C	US-6,795,053	09-2004	Funamoto et al.	345/102
*	D	US-2003/0184500	10-2003	Kang, Seong Ho	345/60
*	E	US-5,734,362	03-1998	Eglit, Alexander Julian	345/89
*	F	US-4,489,349	12-1984	Okada, Takashi	348/674
*	G	US-2004/0234153	11-2004	Nakami, Yoshihiro	382/254
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.